

PATENT COOPERATION TREATY

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_{Ac}	ldress	s:					TTEN OPINION OF			
Address: Nishimura Building, 6-5, Tanimachi 1-chome, Chuo-ku,			INTERNATIONAL SEARCHING AUTHORITY (Implementing Regulation 40 bis)							
		ka-shi, Osaka 54		,,			(PCT Rule 43bis.1)	0 013)		
l					1	Date of mailing				
<u> </u>						(day/month/year)	24. 5. 2005			
Ar	plica	int's or agent's fil	e reference		FOR FURTHER ACTION					
' '	_	IPCT					ee paragraph 2 below			
Int	ernat	ional application	No.	International filing	dat	te (day/month/year)	Priority date (day/m	onth/yea	ır)	
		Г/JP2005/001418		01. 02. 2005			27. 02. 2004	•	•	
Int	ernat	ional Patent Clas	ssification (IPC)	Int. Cl ⁷ H01G 4/12	2	H01G 4/252 H01G 4	1/30			-
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	Μι	ırata Manufa	cturing Co.,	Ltd.						
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1.	Thi	s opinion contain	ns indications rela	ting to the following	ite	ms:				
	×	Box No. I	Basis of the opi	nion						
		Box No. II	Priority	•						
		Box No. III	Non-establishm	ent of opinion with re	ega	rd to novelty, inventive	e step and industrial a	pplicabi	lity	
		Box No. IV	Lack of unity of		•	•	•		·	
	×	Box No. V	Reasoned stater	nent under Rule 43bi	s.1	(a)(i) with regard to no	velty, inventive step o	r indust	rial	
						supporting such stater				
		Box No. VI	Certain docume	ents cited						
		Box No. VII	Certain defects	in the international ar	ppl	ication				
		Box No. VIII	Certain observa	tions on the internation	ona	al application				
2.		RTHER ACTIO								
						e, this opinion will be o ept that this does not ap				
						PEA has notified the In				
	that	written opinions	of this Internation	onal Searching Author	rity	will not be so consider	red.			
						n opinion of the IPEA, ments, before the expir				the
						months from the priori				
	For	further options,	see Form PCT/IS	A/220						
3.	For	further details, s	see notes to Form	PCT/ISA/220						
Da	te of	completion of th	is opinion	10. 05. 2005						
Na	me ai	nd mailing addre	ess of the ISA/JP	10.03.2003		Authorized officer	 r	5R	33	387
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WRITTEN OPINION OF THE INTERNATIONAL SEARCHING AUTHORITY

International application No. PCT/JP2005/001418

Bo	x No	o.]	I Basis of this opinion			
1.			regard to the language, this opinion has been established on the basis of the international application in the language in the it was filed, unless otherwise indicated under this item.			
		1	This opinion has been established on the basis of a translation from the original language into the following language, which is the language of a translation furnished for the purpose of international search (under Rules 12.3 and 23.1(b)).			
2.	2. With regard to any nucleotide and/or amino acid sequence disclosed in the international application and necessary to the claimed invention, this opinion has been established on the basis of:					
a		_	e of material			
			a sequence listing			
		J	table(s) related to the sequence listing			
b	. f	îor	mat of material			
		J	in written format			
		J	in computer readable form			
c.	. ti	im	ne of filing/furnishing			
		נ	contained in the international application as filed.			
		ב	filed together with the international application in computer readable form.			
		J	furnished subsequently to this Authority for the purposes of search.			
3.		1	In addition, in the case that more than one version or copy of a sequence listing and/or table relating thereto has been filed or furnished, the required statements that the information in the subsequent or additional copies is identical to that in the application as filed or does not go beyond the application as filed, as appropriate, were furnished.			
4.	Ad	ldit	tional comments:			

WRITTEN OPINION OF THE INTERNATIONAL SEARCHING AUTHORITY

International application No. PCT/JP2005/001418

Box No. V		Reasoned statement under Rule 43bis.1(a)(i) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement						
1.	Statement							
	Novelty	(N)	Claims	5, 7-9, 11	YES			
			Claims	1-4, 6, 10	NO			
	Inventiv	e step (IS)	Claims	7-9	YES			
			Claims	1-6, 10, 11	NO			
	Industria	al applicability (IA)	Claims	1-11	YES			
			Claims		NO			

2. Citations and explanations:

Document 1: JP 8-97075 A (Murata Manufacturing Co., Ltd.)

April 12, 1996; all pages; Fig. 1

Document 2: JP 8-203770 A (Murata Manufacturing Co., Ltd.)

August 9, 1996; Paragraphs [0010]-[0025]; Fig. 1

Document 3: JP 8-37127 A (Matsushita Electric Industrial Co., Ltd.)

February 6, 1996; Claim 4; Paragraph [0014]; Figs. 1-3

Document 4: JP 2001-200163 A (Matsushita Electric Works, Ltd.)

July 24, 2001; Claims

• Claims 1-6, 10, and 11

Document 1 discloses a monolithic ceramic electronic component and a method for manufacturing such a component. The monolithic ceramic electronic component is manufactured as follows: a conductive paste containing glass is applied onto a ceramic sintered body, small pieces of silver foil are bonded to the conductive paste, a first electrode layer (corresponding to "the sintered electrode layer") and a silver foil-bonded layer lying thereover are formed by baking the resulting conductive paste, and a plated Ni layer (corresponding to "the intermediate electroplated layer") and a plated Sn layer are formed on the silver foil-bonded layer in that order.

Since the plated Ni layer is formed on the silver foil piece-bonded layer, silver contained in the silver foil-bonded layer is determined to correspond to "the metals acting as seeds" cited in Claims 1 and 6.

Accordingly, the invention claimed in Claims 1-4, 6, and 10 lacks novelty and inventive step.

Document 2 discloses a monolithic ceramic electronic component and a method for manufacturing such a component. This monolithic ceramic electronic component is manufactured as follows: a first electrode layer (corresponding to "the sintered electrode layer") is formed by applying a conductive paste containing glass onto a ceramic sintered body and then baking the conductive paste, a second electrode layer is formed on a portion thereof using a conductive resin, and a plated Ni layer (corresponding to "the intermediate electroplated layer") and a plated Sn layer are formed over the first and second electrode layers in that order.

The use of the conductive resin containing metal powder made of copper (Cu) or tin (Sn) is known as disclosed in Documents 3 and 4.

Therefore, those skilled in the art can readily appreciate that the invention claimed in Claims 1-6, 10, and 11 can be made using the above known technique and the conductive resin, disclosed in Document 2, containing metal powder made of tin or the like to manufacture the monolithic ceramic electronic component disclosed in Document 2.

Accordingly, the invention claimed in Claims 1-6, 10, and 11 lacks inventive step.

Claims 7-9

The invention claimed in Claims 7-9 is not disclosed in any of Documents 1-4 and is not therefore obvious to those skilled in the art.